PAGE 2/3 \* RCVD AT 6/9/2004 6:38:15 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-2/1 \* DMIS:7468783 \* CSID:4089389069 \* DURATION (mm-ss):01-02

Palm - 3285.PSI

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: N. Osborn et al.

Serial:

09/773,061

Group Art Unit: 2682

Filed:

January 30, 2001

Examiner: Yuwen Pan

For:

METHOD AND APPARATUS FOR SELECTIVE AND

AUTOMATIC TWO-WAY BEAMING OF RELATED

INFORMATION TO AND FROM PERSONAL INFORMATION

MANAGEMENT SYSTEMS

**EXAMINER INTERVIEW REQUEST** 

Honorable Commissioner for Patents PO Box 1450

Alexandria, VA 22313-1450 Examiner's FAX: 703/746-8783 7/21/04 Wouls

Dear Examiner Pan:

Applicants respectfully request a telephone Examiner Interview in the above captioned case. Applicants further respectfully request that the Examiner's Supervisory Patent Examiner also attend the interview. Applicants have previously requested such an interview via fax on April 14, 2004, and again on May 13, 2004. An interview scheduled for May 19, 2004, was canceled at the Examiner's request.

Applicants respectfully request the interview be scheduled as soon as possible for any time after 9 AM PDT (noon EDT).

1

Palm-3285.PSI/ACM/NAO

Examiner: Y. PAN

Serial No.: 09/773,061

Group Art Unit: 2682

## Topics for discussion include:

- Official Action of 3/10/2004
  - o Response to Arguments
  - o 35 USC § 102 rejections, including
    - Claims 6, 20
    - Claims 1, 8 and 14
  - o 35 USC § 103 rejections
    - Claims 13 and 19
- Cited art
- Other matters that may place the present Application in condition for allowance.

Applicants' Attorney may be contacted regarding the requested Examiner Interview via phone or via email.

Respectfully submitted,	
WAGNER, MURABITO & HAO	LP

Date: \_\_\_\_\_\_ Anthony C. Murabito

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Palm-3285.PSI/ACM/NAO Examiner: Y. PAN

Serial No.: 09/773,061 Group Art Unit: 2682